



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Jaime Poris; Claudio L. Rampoldi  
Assignee: Nanometrics Incorporated  
Title: Method of Determining Material Using Intesity of Light  
Serial No.: 10/634,568 Filing Date: August 4, 2003  
Examiner: Michael A. Lyons Group Art Unit: 2877  
Docket No.: NAN042-1D US Confirmation No.: 6971

Santa Clara, California  
May 25, 2004

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Dear Sir:

This Response to Office Action is responsive to the March 2, 2004, Office Action, which has a statutorily shortened period for response that ends June 2, 2004.

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